

HEWLETT-PACKARD COMPANY
Intellectual Property Administration
P. O. Box 272400
Fort Collins, Colorado 80527-2400

PATENT APPLICATION

ATTORNEY DOCKET NO. 200208154-1

IN THE U.S. PATENT AND TRADEMARK OFFICE

**Mail Stop Patent Application
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450**

Sir:

Transmitted herewith for filing under 37 CFR 1.53(b) is a(n): Utility Design

(x) original patent application

() continuation-in-part application

INVENTOR(S): Jian-gang Weng et al

TITLE: Solution-Processed Thin Film Transistor Formation Method



Enclosed are:

The Declaration and Power of Attorney. signed unsigned or partially signed

(X) 5 sheets of drawings (one set) () Associate Power of Attorney

Form PTO-1449 Information Disclosure Statement and Form PTO-1449

() Priority document(s) (X) (Other) 5G written Authority (fee \$)

CLAIMS AS FILED BY OTHER THAN A SMALL ENTITY				
(1) FOR	(2) NUMBER FILED	(3) NUMBER EXTRA	(4) RATE	(5) TOTALS
TOTAL CLAIMS	32 — 20	12	X \$18	\$ 216
INDEPENDENT CLAIMS	3 — 3	0	X \$84	\$ 0
ANY MULTIPLE DEPENDENT CLAIMS	0		\$280	\$ 0
BASIC FEE: Design (\$330.00); Utility (\$750.00)				\$ 750
TOTAL FILING FEE				\$ 966
OTHER FEES				\$
TOTAL CHARGES TO DEPOSIT ACCOUNT				\$ 966

Charge \$ 966 to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any over payment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16 through 1.21 inclusive, and any other sections in Title 37 of the Code of Federal Regulations that may regulate fees. A duplicate copy of this sheet is enclosed.

"Express Mail" label no. EV 258643741 US
Date of Deposit 7/9/03

Respectfully submitted

Jian-gang Wang et al

By *Wm. T.*

Larry R. Baker

Attorney/Agent for Applicant(s)

Reg. No. 39,593

Date: July 9, 2003

Telephone No.: (541) 715-7331